

PATENTS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Jean-Christophe REMIGY et al.

Serial No. (~~unknown~~) 10/049370

Filed ~~herewith~~ 2.12.02

METHOD FOR PRODUCING A NANOFILTRATION
MEMBRANE AND RESULTING MEMBRANE

SAH
#4
6-18.02

INFORMATION DISCLOSURE STATEMENT

Commissioner of Patents

Washington, D.C. 20231

Sir:

In compliance with Rules 1.97 and 1.98, and in fulfillment of the duty of disclosure under Rule 1.56, the following documents, copies of which are attached to this statement, are made of record on the enclosed sheet.

A concise explanation of the relevance of several of these items is that we are advised by our client that these references were discovered during any searches they or their client had made, or that they were considered in the preparation of the application.

A concise explanation of the relevance of the remainder of these items is that we are advised by our client that these latter references were cited in International Application PCT/FR01/01725 filed June 5, 2001.

Respectfully submitted,

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February 12, 2002

FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT <small>(Use several sheets if necessary)</small> (37 CFR 1.98(b))	ATTY. DOCKET NO. 0509-1003	SERIAL NO.
	APPLICANT Jean-Christophe REMIGY et al.	
	FILING DATE February 12, 2002	GROUP

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		PATENT NUMBER	ISSUE DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA	4,618,533	10/86	Steuck			
	AB	5,256,503	10/93	Cook et al.			
	AC	5,425,865	6/95	Singleton et al.			
	AD	5,468,390	11/95	Crivello et al.			
	AE	5,629,084	5/97	Wilson			
	AF	5,814,372	9/98	Wilson			
	AG						
	AH						
	AI						
	AJ						

FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

		DOCUMENT NO.	PUBL. DATE	COUNTRY OR PATENT OFFICE	CLASS	SUB CLASS	TRANSLATION YES NO
	AL	02 059029	2/90	Patent Abstracts of Japan			yes
	AM	0 823 281	2/98	Europe			yes
	AN	2 688 418	9/93	France			no
	AO	WO 87/06395	10/87	International			yes
	AP	WO 96/03202	2/96	International			yes

OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Place of Publication)

	AR	
	AS	
	AT	

EXAMINER**DATE CONSIDERED**

EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.